

Docket No.: OGOSH54USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/595,856	Confirmation No. 7985
Applicant	:	Haoshen Zhou et al.	
371(c) Date	:	May 16, 2005	
Art Unit	:		
Examiner	:		
Customer No.	:	00270	
Title	:	NANOCRYSTAL OXIDE/GLASS COMPOSITE MESOPOROUS POWDER OR THIN FILM, PROCESS FOR PRODUCING THE SAME, AND UTILIZING THE POWDER OR THIN FILM, VARIOUS DEVICES, SECONDARY BATTERY AND LITHIUM STORING DEVICE	

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

In compliance with their duty to disclose under 37 CFR §1.56(a), Applicants and their attorneys enclose a form PTO-1449 and copies of the foreign and other documents listed therein.

The listed references were cited in the International Search Report for International Application No. PCT/JP04/16981 or are related U.S. patent documents.

The Examiner is respectfully requested to consider the cited documents and to make the same of record in the file of the present application.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.M./

Receipt date: 05/16/2006

In the event that a fee for the Information Disclosure Statement is required, please charge the fee to our Deposit Account No. 08-3040.

Respectfully submitted,  
HOWSON AND HOWSON  
Attorneys for Applicant

By /William Bak/  
William Bak  
Reg. No. 37,277  
501 Office Center Drive  
Suite 210  
Fort Washington, PA 19034  
(215) 540-9216

Form PTO-1449 U.S. Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT	Atty. Docket No. <b>OGOSH54USA</b>	Serial No. <b>10/595,856</b>
	Applicant: Haoshen Zhou et al.	
	371 (c) Date: May 16, 2006	Group Art Unit:

## U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
		5,622,684	4/1997	Pinnavaia et al.	423	702
		5,795,559	8/1998	Pinnavaia et al.	423	702
		2003/0054954 A1	3/2003	Chane-Ching et al.	502	304

## FOREIGN PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Country	Translation	
					Yes	No
		JP 2001-233615	8/2001	Japan	Abstract only	X
		JP 2002-338228	11/2002	Japan	Abstract only	X
		JP 2002-042808	2/2002	Japan	Abstract only	X
		JP 2004-214116	7/2004	Japan	Abstract only	X
		JP 2003-077541	3/2003	Japan	Abstract only	X
		JP 2003-077466	3/2003	Japan	Abstract only	X

Other Documents (including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	/Julian Mercado/	Date Considered 10/13/2009

\*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.